

**Course Schedule, group M16-304****MONDAY**

10:15 — 11:50	■ SEM	Elect	Planar Cycle Technology 🎓 Kozyrev A.A. 📍 FIAN
11:55 — 12:40	■ LEC	Elect	Planar Cycle Technology 🎓 Kozyrev A.A. 📍 FIAN
14:30 — 17:50	■ LEC		Methodology of Science <b>(2018-02-05 — 2018-03-05)</b> 🎓 Arshinov V.I. 📍 404

**TUESDAY**

08:30 — 10:05	■ LEC	Opt	Military Training <b>(2018-02-06 — 2018-04-10)</b> 📍 dep.20
10:15 — 16:05	■ SEM	Opt	Military Training <b>(2018-02-06 — 2018-04-10)</b> 📍 dep.20

**WEDNESDAY**

10:15 — 11:50	■ SEM		Modern Optics 🎓 Kulchin Y.N. 📍 FIAN
11:55 — 12:40	■ LEC		Modern Optics <b>(2018-02-07 — 2018-03-14)</b> 🎓 Kulchin Y.N. 📍 FIAN
	■ SEM		Modern Optics <b>(2018-03-21 — 2018-04-11)</b> 🎓 Kulchin Y.N. 📍 FIAN
12:45 — 14:20	■ SEM		Practical Training (Research Work) 🎓 Popov Y.M., Cheshev E.A., Fronya A.A., Ummarino D., Strigatsti A., Sentis M., Pavichevich Z., Orlovich V.A., Lysenko V., Krohin O.N., Kotova N.E., Kanavin A.P., Dombrovskaya Y., Delaporte F., Bezotosnyy V.V., Barbero D., Zavestovskaya I.N. 📍 FIAN

**THURSDAY**

11:05 — 11:50	■ LEC	Elect	Physics and Technology of Semiconductor Lasers 🎓 Mikaelyan G.T. 📍 64-55
11:55 — 13:30	■ SEM	Elect	Physics and Technology of Semiconductor Lasers 🎓 Mikaelyan G.T. 📍 64-55
14:30 — 16:05	■ LEC		Management of Intellectual Property <b>(2018-02-08 — 2018-03-08)</b> 🎓 Yushkov E.S. 📍 V-415
	■ SEM		Management of Intellectual Property <b>(2018-03-15 — 2018-04-12)</b> 🎓 Yushkov E.S. 📍 V-415
16:15 — 17:50	■ LAB		Latex Basics 🎓 Kuznetsov A.V. 📍 V-116

**FRIDAY**

10:15 — 12:40	■ SEM		Modern Laser Technologies 🎓 Fronya A.A., Choduraev T.M. 📍 FIAN
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